

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKAHIRO YAJIMA ET AL.)
Application No.: Division of Appln. No.)
09/772,988)
Filed: Herewith :)
For: DEPOSITED FILM :)
FORMING APPARATUS AND)
DEPOSITED FILM :)
FORMING METHOD) September 4, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT
AND INFORMATION DISCLOSURE STATEMENT

Sir:

a) Introductory Comments

Prior to receipt of the first action on the merits, kindly amend the subject application as follows: